## Abstract Submitted for the MAR10 Meeting of The American Physical Society

Mechanism for writing and erasing nanostructures at the LaAlO<sub>3</sub>/SrTiO<sub>3</sub> interface using vacuum AFM<sup>1</sup> FENG BI, JEREMY LEVY, DANIELA F. BOGORIN, University of Pittsburgh — Nanoscale control of the metal-insulator transition in LaAlO<sub>3</sub>/SrTiO<sub>3</sub> heterostructure can be achieved using local voltages applied by a conducting AFM probe. One proposed mechanism for the writing process (C.S. Hellberg, unpublished) involves adsorbed H<sub>2</sub>O which dissociates into OH<sup>-</sup> and H<sup>+</sup> which are then selectively removed by a biased AFM probe. To test this mechanism, writing and erasing experiments are performed in a vacuum AFM ( $2 \times 10^{-5}$  Torr) using various gas mixtures. We find that it is not possible to write nanostructures in vacuum or in the presence of several gas mixtures that do not contain H<sub>2</sub>O.

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